

IN THE UNITED STATES PATENT AND TRADEMARK OFFICE

Application Serial No. 09/652,533
Confirmation No 4487
Filing Date August 31, 2000
Inventor Gurtej S. Sandhu et al
Assignee Micron Technology, Inc.
Group Art Unit 2823
Examiner W. Coleman
Attorney's Docket No. MI22-1385
Customer No. 021567
Title: Deposition Methods and Apparatuses Providing Surface Activation

SUPPLEMENTAL INFORMATION DISCLOSURE STATEMENT

In compliance with 37 C.F.R. §§ 1.56, 1.97 and 1.98, your attention is directed to the United States patents and other references listed on the attached Form PTO-1449. No admission is made regarding whether all the submitted references are prior art.


This Supplemental Information Disclosure Statement is being after together with the filing of a Request for Continued Examination (RCE) Application and before receipt of the first Office Action. Therefore, no fee is believed to be required. However, in the event that a fee is required for filing this Supplemental Information Disclosure Statement, please charge the fee specified under 37 C.F.R. §1.17(p) to Deposit Account No. 23-0925. Please credit Deposit Account No. 23-0925 with any overpayment of the above fee.

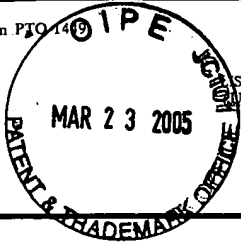
Pursuant to 37 C.F.R. §1.98(a)(2)(ii) no copies of any cited U.S. patents or U.S. published applications are included herewith. Copies of all other cited art references, if any, are attached. No admission is made regarding whether all the submitted references are prior art.

Citation of these references is respectfully requested.

Respectfully submitted,

Date: 23 Mar 2005

Attorney: 
James E. Lake
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Form PTO 1449		U.S. DEPARTMENT OF COMMERCE PATENT AND TRADEMARK OFFICE		ATTY. DOCKET NO. MI22-1385		SERIAL NO. 09/652,533	
 LIST OF ART CITED BY APPLICANT (Use several sheets if necessary)				APPLICANT Gurtej S. Sandhu			
				FILING DATE August 31, 2000		GROUP 2823	
U.S. PATENT DOCUMENTS							
*Examiner Initial	Document Number	Date	Name	Class	Subclass	Filing Date If Appropriate	
AA	6,290,824	3/1994	Ishikawa et al				
AB	2002/0066411	06/2002	Chiang et al				
AC							
AD							
AE							
AF							
AG							
AH							
AI							
AJ							
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AL							
FOREIGN PATENT DOCUMENTS							
Document Number	Date	Country	Class	Subclass	Translation		
					Yes	No	
AM							
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OTHER REFERENCES (including Author, Title, Date, Pertinent Pages, Etc.)							
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